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Notice of References Cited	Application/Control No. 09/815,337	Applicant(s)/Patent Under Reexamination CEDERVALL ET AL.	
	Examiner Nawara T. Omary	Art Unit 2683	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,890,068	03-1999	Faltouche et al.	455/456.2
*	B	US-5,835,857	11-1998	Otten, David D.	455/410
*	C	US-5,973,643	10-1999	Hawkes et al.	342/457
	D	US-			
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	J	US-			
	K	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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